In re PATENT APPLICATION of

Inventor/s: Talieh et al. Appln. No: 09/941,360 Filed: August 28, 2001

FOR: Method and Apparatus for Polishing TRADE

Semiconductor Substrate

Atty. Dkt.: 42496/0269250 Group Art Unit: 1741 Examiner: Wang, E.

Date: November 8, 2001

Commissioner for Patents Washington, D.C. 20231

Sir:

Semiconductor Substrate

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

nissioner for Patents
ngton, D.C. 20231

Applicants submit herewith a Form PTO-1449 citing information of which applicants are aware, which applicants believe may be material to the examination of this application and in respect of which there may be a duty to disclose in accordance with 37 CFR § 1.56.

This Supplemental Information Disclosure Statement:

- (a) [] accompanies the new patent application transmittal submitted herewith. 37 CFR § 1.97(a).
- (b) [] is filed within three months after the filing date of the application or within three months after the date of entry of the national stage of a PCT application as set forth in 37 CFR § 1.491.
- (c) [X] as far as is known to the undersigned, is filed before the mailing date of a first Office Action on the merits.
- (d) [] is filed after the first office action and more than three months after the application's filing date or PCT national stage date of entry filing but, as far as is known to the undersigned, prior to the mailing date of either a final rejection or a notice of allowance, whichever occurs first, and is accompanied by either the fee (\$180) set forth in 37 CFR § 1.17(p) or a certification as specified in 37 CFR § 1.97(e), as checked below.
- (e) [] is filed after the mailing date of either a final rejection or a notice of allowance, whichever occurred first, and is accompanied by the fee (\$180) set forth in 37 CFR § 1.17(i)(1) and a certification as specified in 37 CFR § 1.97(e), as checked below. This document is to be considered as a petition requesting consideration of the Information Disclosure Statement.

While the information cited in this Information Disclosure Statement may be "material" pursuant to 37 CFR § 1.56, it is not intended to constitute an admission that the information referred to is "prior art" for this invention unless specifically designated as such.

In accordance with 37 CFR § 1.97(g), the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information as defined in 37 CFR § 1.56(a) exists. It is submitted that the Information Disclosure Statement is in compliance with 37 CFR § 1.98 and MPEP § 609 and consideration of the foregoing and enclosures, plus the return of a copy of 60249031v1

the enclosed Form PTO-1449 with the Examiner's initials in the left column per MPEP 609 are earnestly solicited, along with an early action on the merits.

<u>CHARGE STATEMENT</u>: The Commissioner is hereby authorized to charge any missing or insufficient fees required relative to this petition, and to credit any overpayment, to our Deposit Account 03-3975/Order No. 42496/259627, for which purpose a duplicate copy of this sheet is enclosed.

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Respectfully submitted, PILLSBURY WINTHROP LLP Intellectual Property Group

By Atty:

Christopher D) Agnew (Registered Patent Agent

Reg. No. 43,464

I, Diana Dearing, certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the U.S. Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on November 2011.